

Mist Elementary School Application Process

2026–2027 School Year



This application process is intended for students who are **not currently enrolled at Mist Elementary School**.

Each student wishing to attend Mist Elementary must complete a separate application. Applications are submitted on an individual student basis; one application per family will not be accepted.

Student selection will be based on a rubric developed from the information provided in the application. The rubric will consider factors such as:

- Residency within the Mist attendance area
- Enrollment of older siblings at Mist Elementary School
- Student attendance history
- Alignment with Mist Elementary School's educational goals and values
- Transportation (The amount of time on district transportation)

Selection decisions will also take into account the school's capacity and its ability to provide the support necessary for each student's success.

This process is designed to ensure a fair and equitable selection procedure while supporting the continued achievement of Mist Elementary School and Vernonia School District goals.

If applicants receive identical rubric scores and available space is limited, ties will be resolved through a random selection process using a random number generator.

Timeline

Application Deadline

Applications for all students interested in attending Mist Elementary School for the 2026–2027 school year must be submitted no later than **8:00 a.m. on Monday, June 22, 2026**.

Application Review

The Mist Application Selection Team will review and score applications using the Mist Application Rubric by **June 25, 2026**.

Tie-Breaking Process (If Necessary)

In the event of identical rubric scores and limited space, a random selection process using a random number generator will be conducted on **June 26, 2026**.

Family Notification

All families will be notified regarding their child's placement for the 2026–2027 school year by **June 30, 2026**.

Application Form

Application Link: <https://forms.gle/hkvof6TQNkuiAvf69>